Se	arcn note	es :

Application/Control No.	Applicant(s)/Patent under Reexamination
10/091,109	LI ET AL.
Examiner	Art Unit
Charles Kim	2623

SEARCHED				
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
Interferen rep		8/4/2005	СК

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
382/155-161,118,224-228; 706/16- 25,45-48; 700/47,48text search (see search report)	8/4/2005	СК
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